

<b>Notice of References Cited</b>	Application/Control No. 09/670,399	Applicant(s)/Patent Under Reexamination WASHIZU ET AL.	
	Examiner Jennine M. Brown	Art Unit 1755	Page 1 of 1

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	U	Washizu and Kurosawa, "Electrostatic Manipulation of DNA in Microfabricated Structures", IEEE Transactions on Industry Applications, Vol. 26, No. 6, November/December 1990.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.